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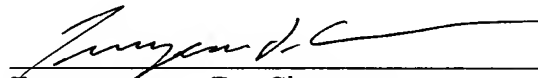
Applicants: Toru IMORI et al
 Title METAL PLATING METHOD, PRETREATMENT AGENT, AND
 SEMICONDUCTOR WAFER AND SEMICONDUCTOR DEVICE
 OBTAINED USING THESE
 Serial No. 10/767 697 Group: 2812
 Confirmation No.: 5592
 Filed : January 29, 2004 Examiner: Unknown
 Atty. Docket No.: Komatsu Case 267A

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on March 18, 2005.

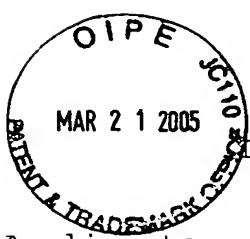

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	Steven R. Thiel	Reg. No. 53 685
	Donald J. Wallace	Reg. No. 43 977
	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement
 dated March 18, 2005
 including enclosures listed thereon

190.05/03



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

March 18, 2005

Applicants : Toru IMORI et al

For : METAL PLATING METHOD, PRETREATMENT AGENT, AND
SEMICONDUCTOR WAFER AND SEMICONDUCTOR DEVICE
OBTAINED USING THESE

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(3) and 1.98, enclosed herewith is Form PTO-1449 and the references cited thereon. This application is a CIP of parent application Serial No. 10/169 778, filed July 2, 2002 (Attorney's reference Komatsu Case 267). The documents listed on the attached Form PTO-1449 were supplied to the Patent Office in the above-identified parent application. Further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

Respectfully submitted,

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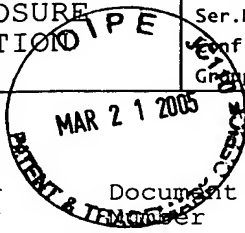
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Reg. No. 43 977
Reg. No. 24 949

Encl: Form PTO-1449 and one copy of each reference listed
thereon

110.0703

INFORMATION
DISCLOSURE
CITATION

Applicant: Toru IMORI et al
Ser.No. : 10/767 697 Filed : January 29, 2004
Ref. No.: 5592 Atty.Ref.: Komatsu Case 267A
Group : 2812



U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date
	AA 4 986 848	1/1991	YAMAMOTO et al			
	AB					
	AC					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation Yes No
	AD 59-52701	12/1984	Japan	English Abstract	attached	
	AE 60-181294	9/1985	Japan	English Abstract	attached	
	AF 61-194183	8/1986	Japan	English Abstract	attached	
	AG 3-44149	7/1991	Japan	English Abstract	attached	
	AH 6-256358	9/1994	Japan	English Abstract	attached	
	AI 63-227784	9/1988	Japan	English Abstract	attached	
	AJ 63-270474	11/1988	Japan	English Abstract	attached	
	AK 11-92482	4/1999	Japan	English Abstract	attached	
	AL 1-117089	5/1989	Japan	English Abstract	attached	
	AM 11-288940	10/1999	Japan	English Abstract	attached	
	AN 2 324 538	10/1998	Great Britain			

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

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EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.